



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Art Unit: 2815

Examiner: Mr. William F. Kraig

In re PATENT APPLICATION of:

Applicant	:	Akira TAKAHASHI)	
)	
Serial No.	:	10/798,482)	
)	
Filed	:	March 12, 2004)	<u>AMENDMENT</u>
)	
For	:	DRY ETCHING METHOD FOR SEMICONDUCTOR DEVICE)	
)	
Attorney Ref.	:	OKI 414)	

December 5, 2006

Director of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is responsive to the Office Action of June 5, 2006, the period for reply to which is being extended to expire on December 5, 2006 by a Petition filed concurrently herewith.

A fee of \$ 1020 is also being submitted concurrently. Should this remittance be accidentally missing, however, or should any additional fees be needed, the Director may charge such fees to our Deposit Account number 18-0002.

Please amend the above-identified application as specified on the following pages, and then reconsider the application in view of the Remarks that are presented thereafter.